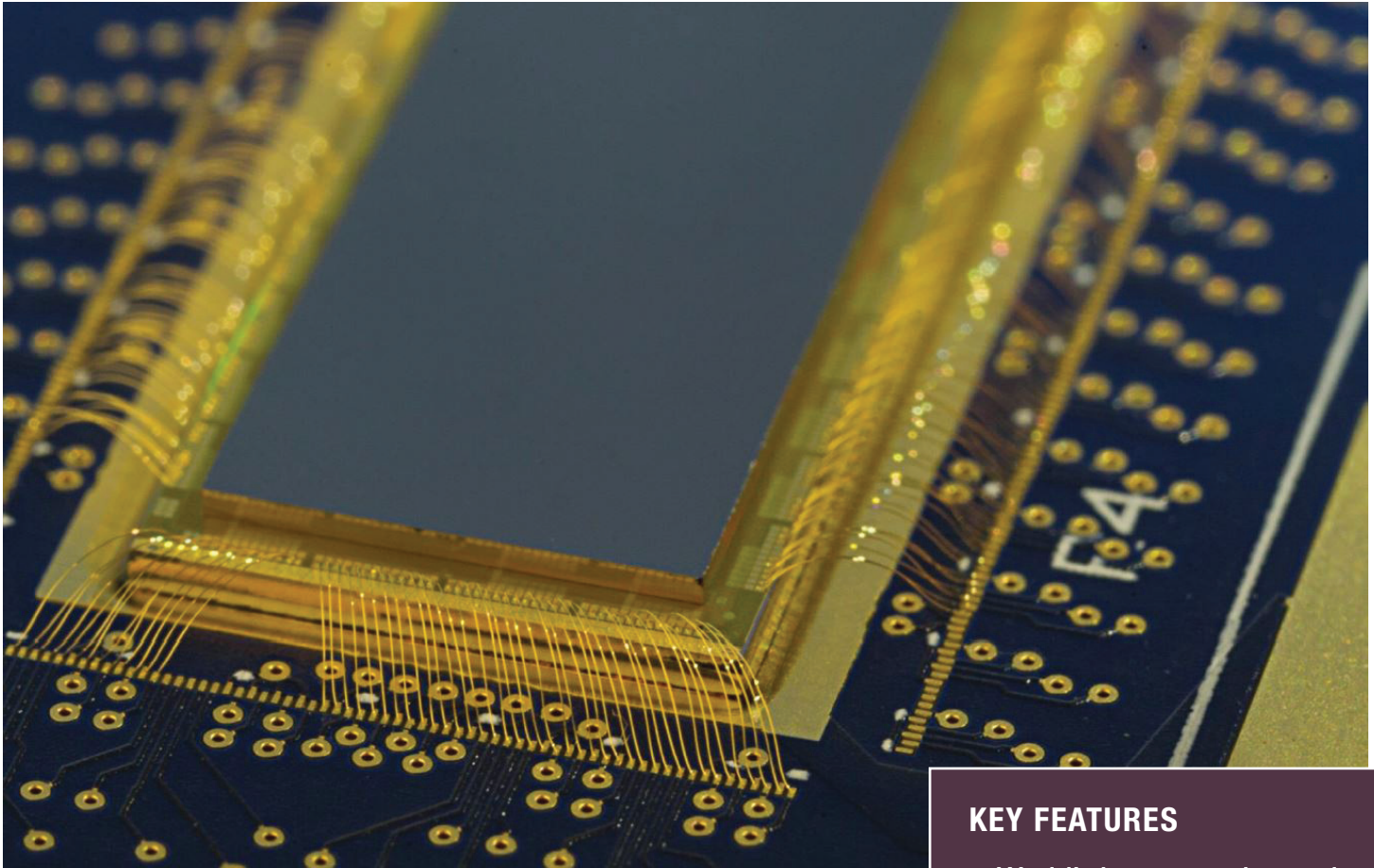


SPOTLIGHT ON

Advanced Imaging Technology



Digital focal plane array.

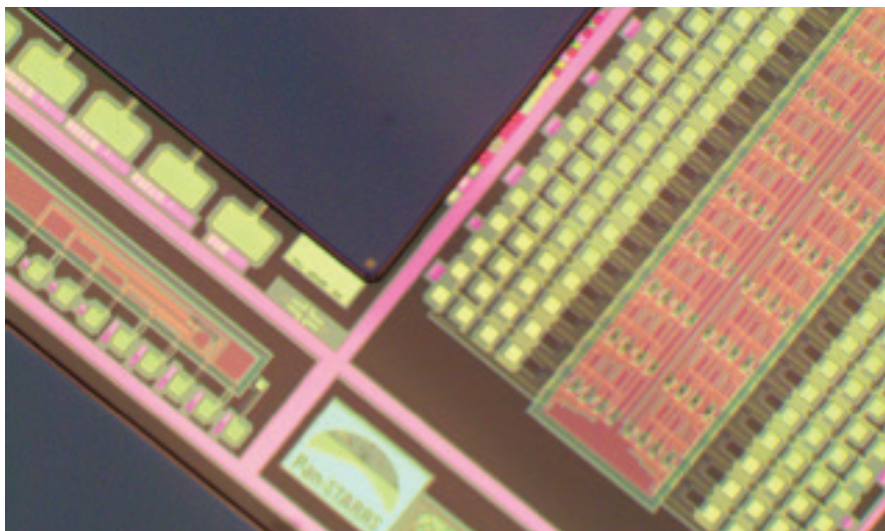
MIT Lincoln Laboratory has long been a leader in advanced imaging for defense and scientific applications. Our imaging capabilities are broadly classified into three categories: charge-coupled devices (CCDs), avalanche photodiodes (APDs), and digital focal plane array (DFPA) technology.

KEY FEATURES

- World's lowest readout noise, highest quantum efficiency CCD imagers
- Geiger-mode (GM) APDs with single-photon sensitivity and noiseless digital readout
- DFPA's containing a complete analog-to-digital converter in every pixel, enabling image processing on the focal plane

Charge-Coupled Devices

Our CCDs are used in ground, air, and space-based applications of interest to the government and scientific research community. These CCDs span a range of wavelengths including visible, near infrared, ultraviolet, and soft X-ray. Among imagers employing our CCDs are the two 1.4-billion-pixel Panoramic Survey Telescope and Rapid Response System's (Pan-STARRS) focal plane arrays, the largest focal planes fabricated to date, and the Space Surveillance Telescope's curved focal planes that provide a uniform and wide field of view.



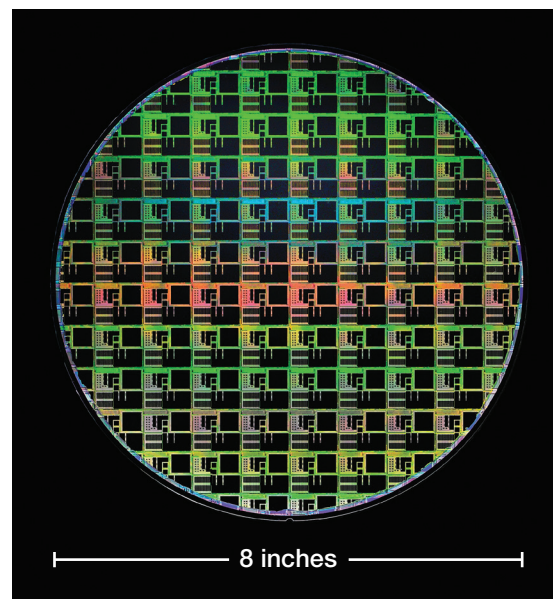
Optical micrograph of back-illuminated CCD wafer.

Geiger-Mode Avalanche Photodiodes

For passive imaging, the noiseless readout of our GM-APDs enables photon counting, providing both the requisite sensitivity for low-light applications and photon count rates for high-speed imaging. APDs are also employed in active lidar systems to time-stamp photon arrival times, enabling 3D imaging in compact airborne systems. We also fabricate APD arrays on compound semiconductor materials, expanding these capabilities further into the infrared.

Digital Focal Plane Array

Our DFPAs enable sensors with in-pixel computation and inter-pixel data communication to allow image processing at the focal plane prior to transmitting data to a display or computer. DFPAs have been built into a number of systems for use in infrared imaging applications. Fielded systems have helped protect soldiers at forward operating bases, while prototype systems have demonstrated wide-area motion imagery from an airplane and assisted pilots when landing helicopters in degraded-vision environments.



Processed APD wafer.

Going Forward

- Utilize new architectures and fabrication techniques to combine the exquisite uniformity and sensitivity of CCDs with the low voltages and high speeds of CMOS imagers
- Take advantage of on-focal plane processing capability to improve information extraction and enable a new generation of autonomous imaging sensors

TECHNICAL CONTACT

Daniel Ripin

Advanced Imager Technology Group



MIT Lincoln Laboratory,
244 Wood Street, Lexington, MA 02421



dripin@ll.mit.edu

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